



Serial No. 09/605,660
SEC. 736

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of

Choung Hyep KIM

Serial No. 09/605,660

Filed June 28, 2000

Group Art Unit 2825

Examiner V. Yevsikov

APPARATUS FOR AND METHOD OF HEAT-TREATING A WAFER

AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Non-Fee Amendment**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

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DEC 29 2003
TECHNOLOGY CENTER 2800

Sir:

In response to the Office action of October 8, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.